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PATENT APPLICATION

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Application of:  Takehiko IWANAGA				) : )		Examiner: P. B. Kim		
Application No.: 10/775,085				: ) :	Group Art Unit: 2851  Confirmation No.: 1601			
Filed: February 11, 2004				)				
For: SCANNING EXPOSURE APPARATUS				:	May 11, 2005			
X No ac	for Patents A 22313-1450	equired.	the above-identi	fied ap	plication.			
The fee has bee	en calculated as s	snown beid		ENIDED		<del></del>		
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	P	RESENT EXTRA	RATE	ADDITIONAL FEE	
TOTAL CLAIMS	4	MINUS	20	=	0	x \$25 \$50	\$0.00	
INDEP. CLAIMS	2	MINUS	4	=	0	x \$100 \$200	\$0.00	
Fee for Multiple	Dependent claims	\$180/\$360				:	_	
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT							\$0.00	
	fied Statement c		nall entity status i	s enclo		iled previous	ly.	

Page 1 of 2

	Charge \$ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed.					
X	Any prior general authorization to charge an issue fee under 37 CFR 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 CFR 1.16 and 1.17 which may be required during the entire pendency of this application or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.					
	A check in the amount of \$ to cover the fee for a month extension is enclosed.					
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.					
X	Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address given below.					
	Respectfully submitted,					
	Attorney for Applicant Lawrence A. Stahl Registration No. 30,110					

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

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For: SCANNING EXPOSURE APPARATUS	;	May 11, 2005

## Mail Stop Amendment

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

### **AMENDMENT**

Sir:

In response to the Official Action dated March 9, 2005, please amend the aboveidentified application as follows: